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Docket No.: NOG-0017
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yoshiaki Noda et al.

Application No.: 10/669,055

Confirmation No.: 3382

Filed: September 24, 2003

Art Unit: 1746

For: PLASMA CLEANING DEVICE

Examiner: Not Yet Assigned

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

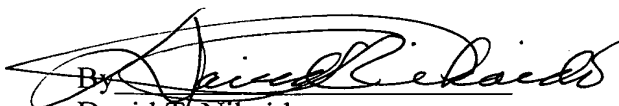
Dear Sir:

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive a First Office Action from the Patent and Trademark Office.

No fee is incurred by filing this inquiry.

Dated: September 24, 2004

Respectfully submitted,

By 

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